

# Woo-Sig Min

## List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/3983132/publications.pdf>

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#	ARTICLE	IF	CITATIONS
1	Fabrication of Planar Heating Chuck Using Nichrome Thin Film as Heating Element for PECVD Equipment. Electronics (Switzerland), 2021, 10, 2535.	3.1	1
2	Planar heating chuck to improve temperature uniformity of plasma processing equipment. Japanese Journal of Applied Physics, 2020, 59, SJJ01.	1.5	6